

12-79-04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.	
Confirmation No.	4650
	August 31, 2000
Inventor	Vishnu K. Agarwal, et al
	Micron Technology, Inc.
	2813
	T. Nguyen
	Ml22-1518
	021567
Title - Full and all Confess And - Consession F	

Title: Enhanced Surface Area Capacitor Fabrication Methods.

RESPONSE TO SEPTEMBER 27, 2004 OFFICE ACTION

To:

MS Amendment

Commissioner for Patents

PO Box 1450 Art Unit 2813

Alexandria, VA 22313-1450

From:

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AMENDMENTS